

In re Patent Application of

New York, New York

Sam-Chul HA et al

Serial No.:

09/894,340 034

Group Art Unit:

Filed:

June 28, 2001

Examiner: Thi D. Dang

For:

CONTINUOUS PROCESSING APPARATUS BY PLASMA

POLYMERIZATION WITH VERTICAL CHAMBER

Asst. Commissioner for Patents Washington, D.C. 20231

## AMENDMENT/SUBMISSION

RECEIVE! This is a response to the Office Action mailed August 9, 2002 in the above-identified application. Reconsideration of the application is respectfully requested.

## FEE CALCULATION

Any additional fee required has been calculated as follows:

If checked, "Small Entity" status is claimed.

NO. CLAIMS				HIGHEST NO	).					
AFTER			<b>PREVIOUSL</b>	Y					ADDIT.	
	AMENI	MEN	T	PAID FOR	EX	XTRA PRES	EN	T	RATE	FEE
TOTAL	,	25	MINUS	27	* =	C	)	X	(\$9 SE or \$18)	\$
INDEP.		4	MINUS	8	** =	4	1	X	(\$42 SE or \$84)	\$336.00
FIRST I	PRESENT	<b>FATIO</b>	ON OF MU	JLTIPLE DEP	ENDEN	Γ CLAIM		X	(\$140 SE or \$280)	\$

<sup>\*</sup> not less than 20 \*\* not less than 3

TOTAL \$336.00

If any additional payment is required, a check which includes the calculated fee of \$252.00 (OFGS Check No. 14451 ) is attached.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee during the prosecution of this application is not paid, the Patent Office is authorized to charge the underpayment to Deposit Account No. 15-0700.